



EPW

Attorney Docket No. 5649-921

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Gi-Jung Kim et al.
Serial No. 10/601,475
Filed: June 23, 2003

Confirmation No. 7249
Group Art Unit: 1775
Examiner: Elizabeth D. Ivey

For: **SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES
THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING
PARTICULATE CONTAMINATION AND METHODS OF FORMING SAME**

May 1, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1451

AMENDMENT A

Sir:

This response addresses the Official Action of February 3, 2006.